

**DOCKET NO. 91-C-134D2 (STMI01-00098)**  
**Customer No. 30425**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of : RAVISHANKAR SUNDARESAN  
United States Serial No. : To Be Assigned  
Filing Date : Herewith  
Title : METHOD OF FORMING ASYMMETRICAL  
POLYSILICON THIN FILM TRANSISTOR (AS  
AMENDED)

**MAIL STOP PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PRELIMINARY AMENDMENT**

Prior to examination of the requested divisional patent application, please amend the above-identified application as follows: